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CONFIRMATION NO. 4915

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SERIAL NUMBER 10/762,361	FILING DATE 01/23/2004  RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. OKI.206D3
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*  
 This application is a DIV of 10/320,660 12/17/2002 PAT 6,700,167  
 which is a DIV of 09/759,639 01/16/2001 PAT 6,528,854 *WLL*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 JAPAN 2000-010250 01/17/2000 *WLL*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 04/26/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 23	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>WLL</i>	Initials		

ADDRESS  
 20987  
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TITLE  
 METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE INCLUDING A MOSFET WITH NITRIDE  
 SIDEWALLS

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees ( Filing )